

Development of Pollution Gas Sensors for the Energy Saving in a Clean Room

Kyoji Shibuya, Dzung Viet Dao and Yutaka Yamagishi

Keywords: Semiconductor gas sensor, WO_3 , Low power consumption, Draft exhaust control

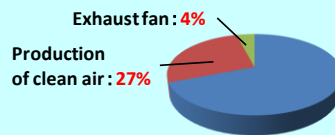
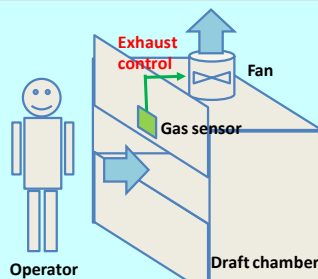
Abstract

- ◆ Low-power and high-sensitivity WO_3 gas sensors are developed.
- ◆ The gas sensors contribute to the energy saving in a clean room by the draft exhaust control.

Objective

Development of low-power and high-sensitivity WO_3 gas sensors which can detect pollution gases (acid and alkaline gases) in ppb level in a clean room

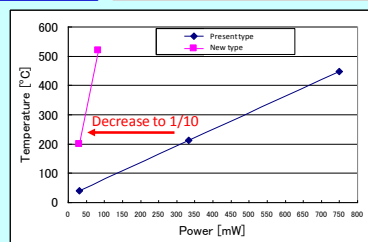
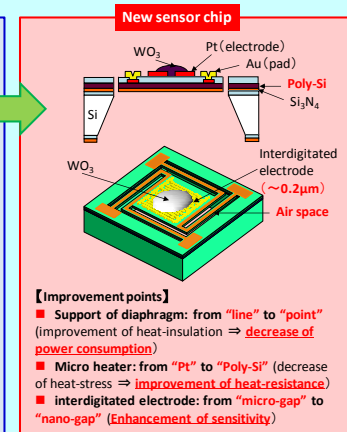
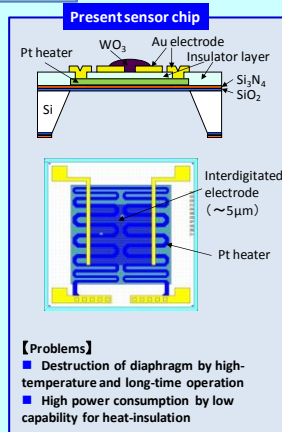
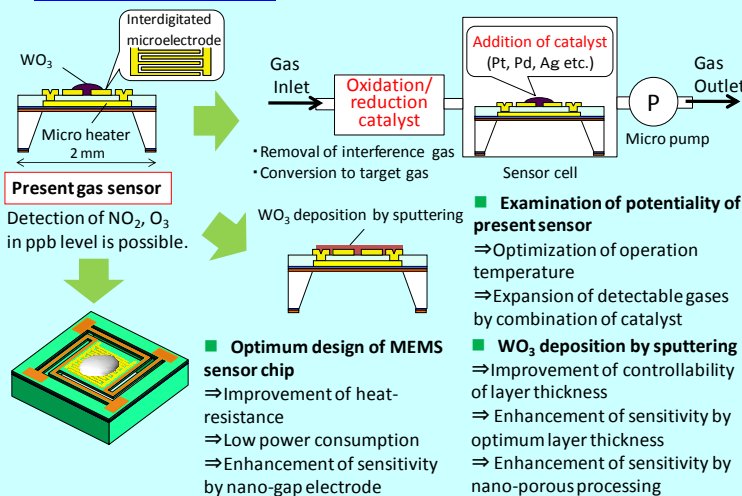
By the control of the exhaust fan of the draft chamber according to the concentration of the pollution gases, not only the power consumption of the exhaust fan but also the power consumption concerning the clean air production is reduced.



Proportion of the energy consumption in a clean room

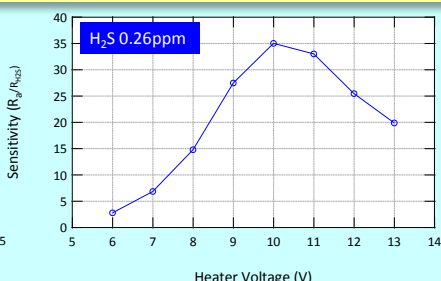
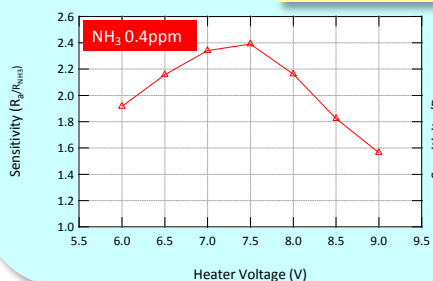
Effect of the energy saving: ▲5%

Methods



Results

NH_3 and H_2S were detected in ppb level and the power consumptions were reduced to 1/2~1/3 in first trial sensors. Now second trial sensors are under evaluation.



Kind of gas	Version of sensor	Max. Sensitivity (Ra/Rg)	Power consumption (@Max. sensitivity) (mW)
NH ₃	Present	1.7@0.5ppm	112
	First trial	2.4@0.4ppm	60
H ₂ S	Present	8.8@0.5ppm	288
	First trial	35@0.26ppm	102